

**AMENDMENTS TO THE CLAIMS**

The following listing of claims will replace all prior versions, and listing of claims in the application:

**LISTING OF CLAIMS:**

Claims 1 – 5 (Cancelled).

Claim 6 (Currently amended): A The method as recited in claim 1, wherein for fabricating an electroluminescent device with a drying film, comprising the steps of:

providing a substrate;

forming, in sequence from substrate up, a transparent electrode, a luminescent layer, and an opposed electrode; and

forming a drying film, by providing a raw material to react with a gaseous reactant, on the surface of said opposed electrode, said step of forming said drying film is formed including the step of forming said drying film on the surface of said opposed electrode in a chamber wherein said gaseous reactant is provided by a gaseous reactant supplier and then flows in a path towards a channel through which said raw material passes.

Claim 7 (Currently amended): The method as recited in claim 6, further comprising the step of providing wherein an isolating member is provided to attach the lateral side of said opposed electrode.

Claim 8 (Currently amended): A The method as recited in claim 1, wherein for fabricating an electroluminescent device with a drying film, comprising the steps of:

providing a substrate;

forming, in sequence from substrate up, a transparent electrode, a luminescent layer, and an opposed electrode; and

forming a drying film, by providing a raw material to react with a gaseous reactant, on the surface of said opposed electrode, said raw material is being introduced towards said opposed electrode by one of the way a process selected from the group consisting of evaporation and sputtering.

Claims 9 – 22 (Cancelled).

Claim 23 (Currently amended): A ~~The~~ method as recited in claim 18, wherein for fabricating a drying film, comprising the steps of:

providing a raw material to react with a gaseous reactant and forming a drying film on the surface of a device, said step of forming said drying film including the step of forming said drying film is ~~formed~~ on the surface of said device in a chamber wherein said gaseous reactant is provided by a gaseous reactant supplier and then flows in a path towards a channel through which said raw material passes.

Claim 24 (Currently amended): A ~~The~~ method as recited in claim 18, wherein for fabricating a drying film, comprising the steps of:

providing a raw material to react with a gaseous reactant;  
forming a drying film on the surface of a device; and  
providing an isolating member is ~~provided~~ to attach the a lateral side of said device.

Claim 25 (Currently amended): A The method as recited in claim 18, wherein for fabricating a drying film, comprising the steps of:

providing a raw material to react with a gaseous reactant and forming a drying film on the surface of a device, said raw material ~~is~~ being introduced towards said device by ~~one of the way~~ a process selected from the group consisting of evaporation and sputtering.